Search Notes



Application/Control No.	Applicant(s)/Patent under Reexamination	
10/811,741	LAM ET AL.	
Examiner	Art Unit	
Paul D. Kim	3729	

SEARCHED				
Class	Subclass	Date	Examiner	
29	417 603.09 603.15 603.16 603.18	12/29/2005	PK	
360	121 125 126	12/29/2005	PK	
	316 317			
451	4,51	12/30/2005	PK	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
- 1 - 1					
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
Reviewed Parent Application 10/097,294 (US PAT. 6,950,289)	12/29/2005	PK	
Text Search EAST/NPL (IEEE)	12/30/2005	PK	
Updated Text Search EAST	5/4/2006	PK	
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